1-17

Active Vibration Isolation Workstation

Active vibration isolation workstation comprises of

ergonomic rigid frame, guarding armrest and sup-

plied with three modifications of active vibration

isolation system: 1TS-140 with solid surface, 1TS-140B with honeycomb breadbord 1HB05-06-025-

001 and 1TS-140B-AL with aluminium breadbord

1B-AL-50-60-015. The control panel is built into the

frame and allows comfortable work. This system is

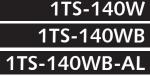
extremely convenient to use. Load compensation

is performed automatically on switching on the

power. If the load is changed whilst the system is

isolating, it automatically readjusts and then returns

1TS-140WB-

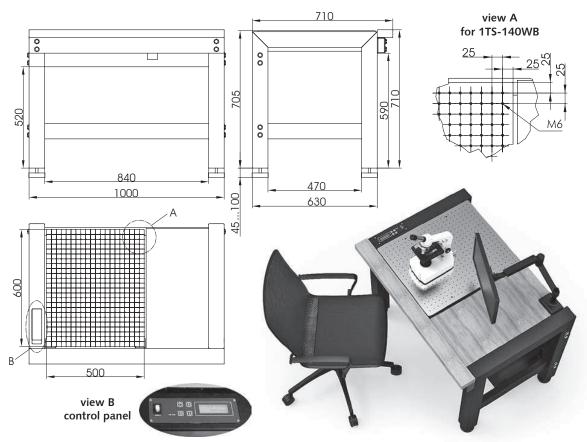


APPLICATIONS

- Scanning probe microscopy
- Scanning electron microscopy
- Scanning near-field optical microscopy / NSOM
- Control laser microscopy
- Interferometry
- Metrology / Profilometry
- Nano indentation
- Nano lithography
- Ultrathin film applications
- Analytical balances
- Bio-physical measurement
 - * Single molecule investigations
 - * Cell micro infection * Cell manipulation
 - * Patch clamp
- * IVF techniques

to the isolation mode. The workstation is design is optimized for such delicate instruments as AFM's, Laser Scanning Microscopes, SNOM's, profilometers, nanoindenters, etc.

Upon request we can make custom workstations with working surfaces 400 x 450 mm (maximum load 150 kg) and 600 x 800 mm (maximum load 120 kg).



ORDERING INFORMATION

1TS-140W - with active system 1TS-140 1TS-140WB - with active system 1TS-140B 1TS-140WB-AL - with active system 1TS-140B-AL

more info about Active System 1TS-140 on page 1-15.

Ideal for use with interferometers, atomic force microscopes, scanning near field optical microscopes, and other equipment sensitive to low frequency vibrations.



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